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# Introduction to Nanotechnology and Nanoscience – Class#2

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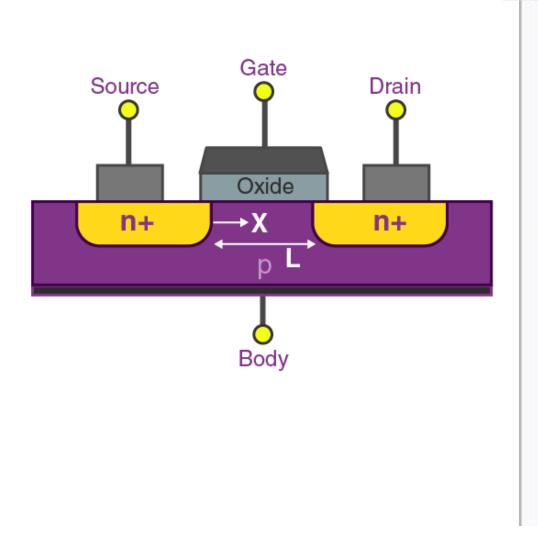
# Outline

Microsystems Laboratory UC-Berkeley, ME Dept.

- □Nanoscale Properties
- □Nanofabrication: Top-down Technologies & Bottom-up Processes
- □(some materials from Professor Lydia Sohn)



# **MOSFET History**



MOSFET scaling (process nodes) 10 µm – 1971 6 µm – 1974 3 µm - 1977 1.5 µm - 1981 1 µm – 1984 800 nm - 1987 600 nm - 1990 350 nm - 1993 250 nm - 1996 180 nm - 1999 130 nm - 2001 90 nm - 2003 65 nm - 2005 45 nm - 2007 32 nm - 2009 22 nm - 2012 14 nm - 2014 10 nm - 20167 nm – 2018 5 nm - 20203 nm - 2022 Future 2 nm ~ 2024



## Why Intel Stock Spiked, Then Crashed, Last Week After Its (Jan, 2023) New CEO Addressed Investors

- The market didn't appear to like new CEO Pat Gelsinger's "stay the course" strategy, but it's the right move long-term.
- Why Gelsinger's comments may have disappointed some
- Investors chasing Intel might have hoped its new CEO would announce more outsourcing of its manufacturing to **Taiwan Semiconductor Manufacturing** (NYSE:TSM). Such a move would probably improve Intel's competitiveness in the short-term, as Taiwan Semiconductor has already successfully begun producing 5nm chips. Meanwhile, Intel's struggles have put it well behind TSMC, and Intel now expects its 7nm chips (equivalent to TSMC's 5nm), out by the first half of 2023. Therefore, short-term investors were hoping Intel might quit trying to run its own fabs and become just a designer of chips, with outside foundries such as TSMC taking up the difficult manufacturing burden.



# TSMC to launch chipmaking plant in Japan, but US plant to face delays

Amber WANG Thu, January 18, 2024 at 3:57 AM PST · 3 min read "In Japan, we are building a special technology fab(rication plant) in Kumamoto which will utilize 12- and 16-nanometre and 28- and 22- nanometer process technology ... The volume production is on track for fourth quarter of 2024" said Liu.

"Fabrication facility in Arizona US is on track for N4 or 4 nanometer in the first-half of 2025 ... have run into issues, which TSMC attributed to a shortage of skilled workers."



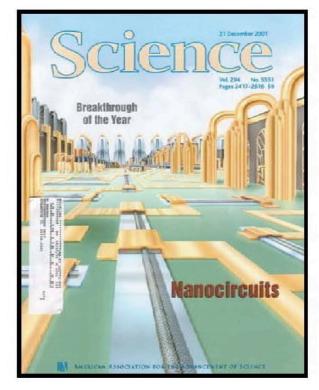
# Nanotechnology Explosion



July 23, 2001



September, 2001



December 21, 2001



# Some big numbers

# Federal 2002 nanofunding\$622 millionEstimated nanosales volume in 2015\$1.2 trillionStates with active nanodevelopments24



# Why should I take this course?



## "Nanoscience & ME"

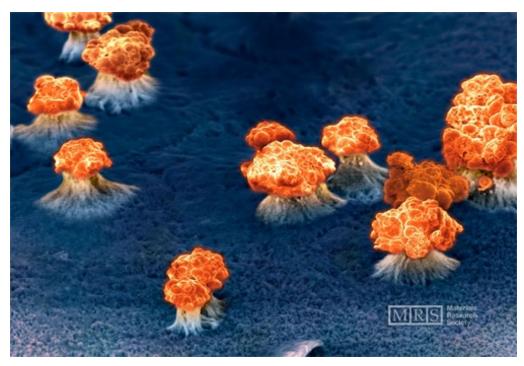
# *What does a mechanical engineer do in nanoscience?*

Materials scientist? Chemical engineer? Chemist, bioengineer, biologist, physicist, civil engineer?



## Research

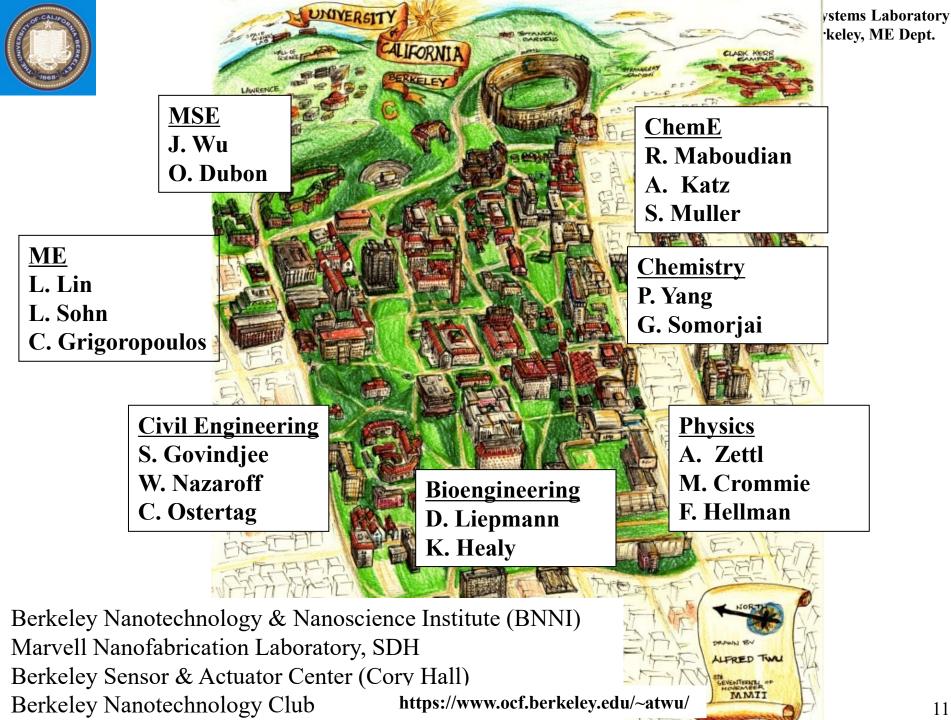
# Nanoscience is hot! National labs, academia, industrial research organizations (IBM, PARC)



"Nano-Explosions" Color-enhanced scanning electron micrograph of an overflowed electrodeposited magnetic nanowire array (CoFeB), where the template has been subsequently completely etched. It's a reminder that nanoscale research can have unpredicted consequences at a high level.

- Fanny Beron, École Polytechnique de Montréal, Montréal, Canada

http://www.mrs.org/science-as-art/





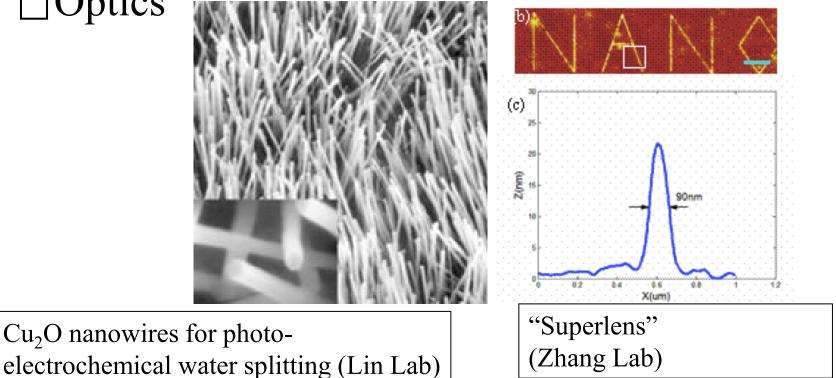
**Mechanical Engineering** 

NanoScience in

□Energy – energy storage, renewable energy

□ Sensing – gas sensors, chemical sensors, etc.

□ Optics





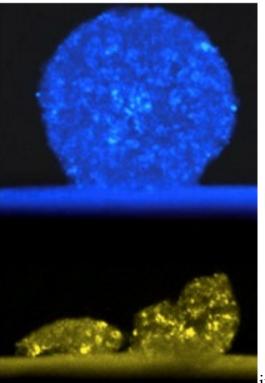
# NanoScience in Materials Science

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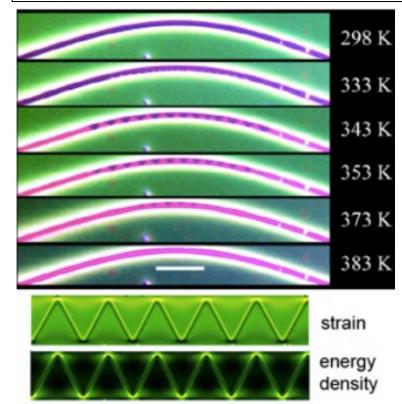
### □Nanomaterial synthesis, material properties,

#### and characterization

In-situ TEM nanomechanics (Andrew Minor Lab)



Strain engineering of VO<sub>2</sub> nanobeams (Junqiao Wu Lab)





# NanoScience in Bioengineering

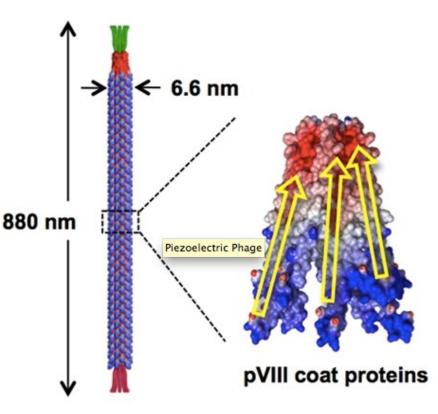
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#### □Virus-based piezoelectric energy generation

- □ Super-resolution imaging
- □Drug delivery

Seung-Wuk Lee Lab:

M13 bacteriophage piezoelectric generator 6 nA, 400 mV Operates a liquid crystal display



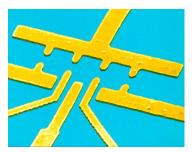


# NanoScience in Physics <sup>Mic</sup> & Chemistry

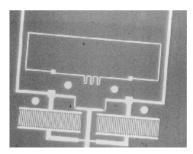
#### Microsystems Laboratory UC-Berkeley, ME Dept.

### □Physics

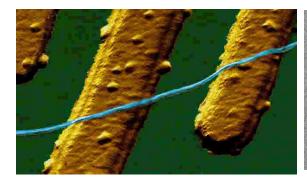
- Nanomechanics
- quantum computation
- quantum teleportation
- artificial atoms
- □Chemistry
  - carbon nanotubes
  - Nanowires
  - self-assembly
  - structures based on DNA
  - supermolecular chemistry



Lateral Quantum Dot Leo Kouwenhoven



Superconducting QuBit John Clarke



Alivisatos Group UC Berkeley 10 nm ECS

Carbon Nanotube Cees Dekker

Tetrapod Paul Alivisatos



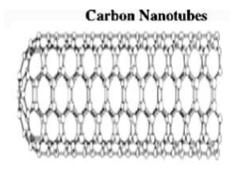
## NanoScience in **Civil Engineering** □ Materials – nano-reinforced materials

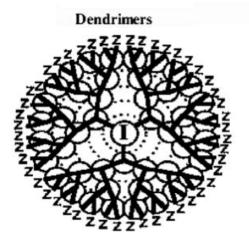
**Microsystems Laboratory** UC-Berkeley, ME Dept.

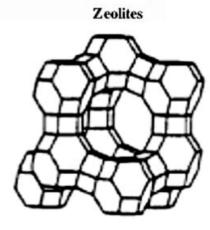
# □ Environmental chemistry

#### □ Water treatment

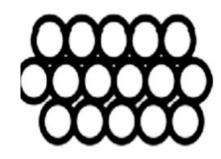
Nanomaterials for water purification: Journal of Nanoparticle Research (2005) 7: 331–342





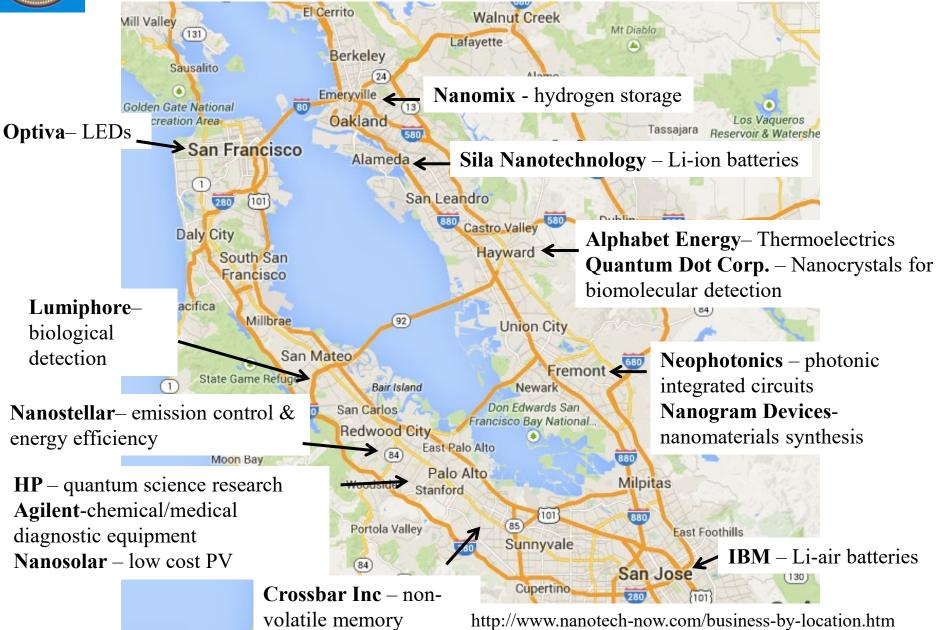


Metal-Oxide Nanoparticles





# Nanotech in the Bay Area Microsystems Laboratory ME Dept.







Scanning electron microscope image of a copper oxide cluster, 3.5 microns in diameter, prepared by evaporation and condensation over an alumina substrate. The smiley nose and eye are present in the original SEM image, which has only been color-enhanced.

- Elisabetta Comini, University of Brescia, Italy

#### http://www.mrs.org/s10-science-as-art-winners/



# Why Nanostructures?

#### $\square$ IC & MEMS > 100 nm

- Batch manufacturing low cost
- Multi-domain Integration (Electrical, mechanical, fluidic, optical ...)
- $\Box$  Nanotechnology < 100 nm
  - Quantum effects in nanostructures (quantum dots, wires, tubes ...)
  - High surface area to volume ratio high sensitivity



# Size-Dependent Properties

At the nanometer scale, properties become size dependent!

For example,

- Thermal properties
- Mechanical properties
- Optical properties
- Electrical properties
- Magnetic properties

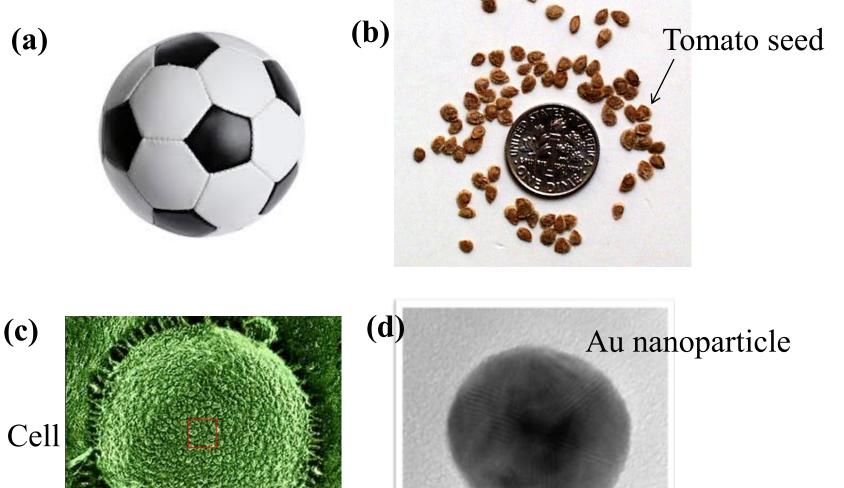
New properties enable new applications

**Microsystems Laboratory** 



### Surface Area to Volume Ratio

**(a)** 



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5 nm

http://web2.clarkson.edu/programs/goia\_g

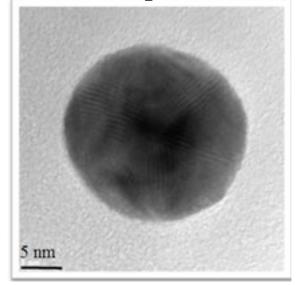
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# **Chemical reactivity**



Au nanoparticle



Catalyst

Inert

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VS

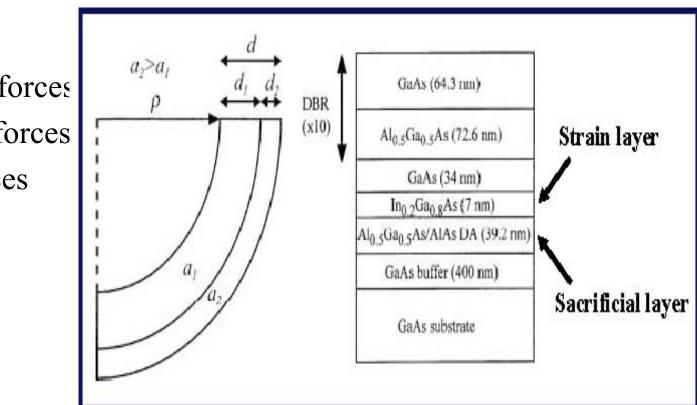


# **Mechanical Properties**

 $\Box$  At the nanoscale, surface and interface forces become dominant.

 $\Box$  For example,

Adhesion forces Capillary forces Strain forces

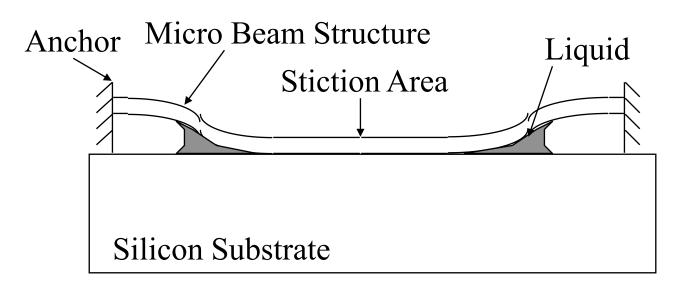


Surface coatings are extremely important to prevent sticking in nanoscale electro-mechanical systems (NEMS)



# Stiction in Micro/Nano Structures

□ Strong capillary forces during the releasing process and pin down the free-standing microstructure



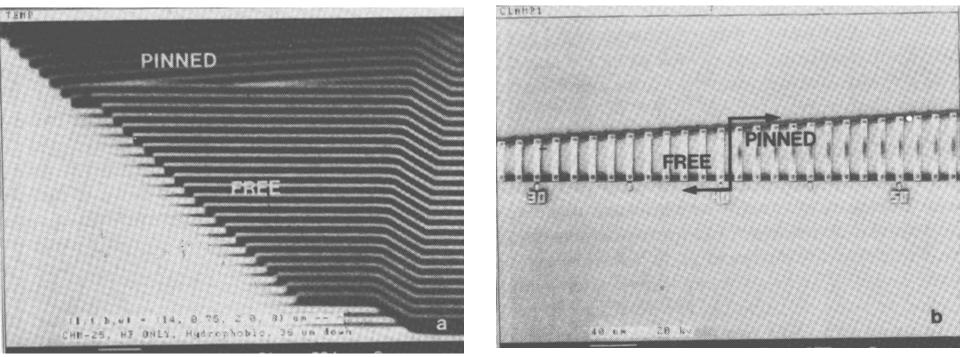


Mastrangelo et al., "Mechanical Stability and Adhesion of Microstructures Under Capillary Forces," IEEE/ASME J. of Microelectromechanical Systems, Vol. 2, 44-55, 1993

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# Microstructure Stiction Examples

☐ Shorter beams may survive stiction problems\*



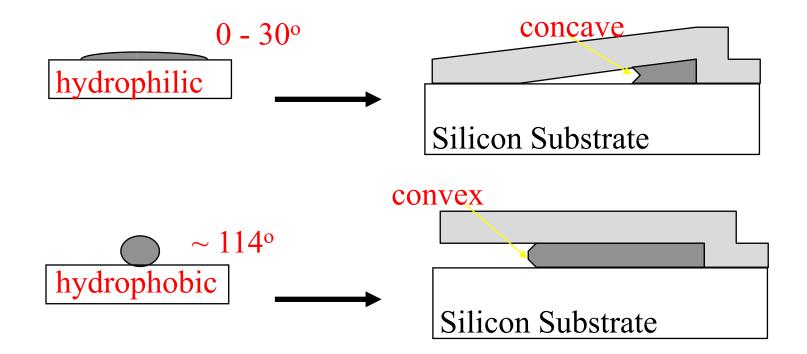
\*Carlos Mastrangelo, Univ. of Michigan



# **Anti-Stiction Coating**

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□ Self-assembled monolayer (SAM) coating by using OTS (octadecyltrichlorosilane) - C<sub>18</sub>H<sub>37</sub>SiCl<sub>3</sub>





# Melting Temperature

# Nanocrystal size decreases Surface energy increases Melting point decreases

#### 3 nm CdSe nanocrystal melts at 700 K compared to Bulk CdSe at 1678K